

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q93989

Osamu ITO, et al.

Appln. No.: 10/573,039

Group Art Unit: 1793

Confirmation No.: 4432

Examiner: Guinever S. GREGORIO

Filed: March 22, 2006

For: PROCESS FOR PRODUCING RADIOACTIVE FLUORINE COMPOUND

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 22, 2008, please consider the remarks as follows on the accompanying pages.

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